



ELECTRONIC COPY

LG790608079
Report verification at igi.org



April 27, 2026

IGI Report Number **LG790608079**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **17.55 X 12.34 X 7.26 MM**

GRADING RESULTS

Carat Weight **10.02 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

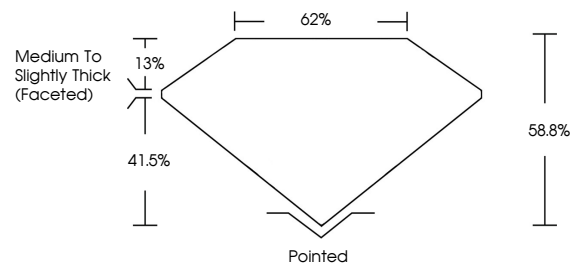
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG790608079**

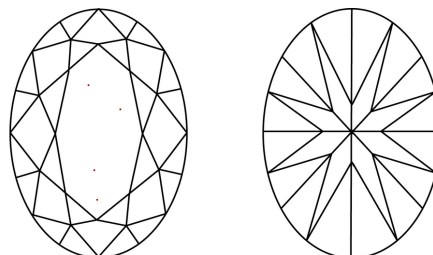
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

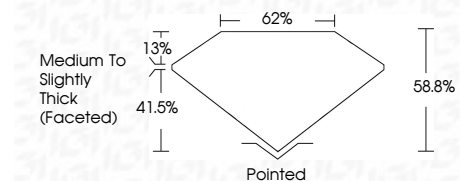
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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Fluorescence **NONE**

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IGI



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IGI Report No LG790608079
OVAL BRILLIANT
17.55 X 12.34 X 7.26 MM
10.02 CARATS
F
Carat Weight
Color Grade
Clarity Grade
Depth
Table
Girdle
Medium to Slightly Thick (Faceted)
Culet
Polish
Symmetry
Fluorescence
Inscription(s)
Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG790608079

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